Hierarchical resource management in grid computing

Korkhov, V.V.

Citation for published version (APA):
Bibliography


References


[71] V. V. Krzhizhanovskaya, M. A. Zatevakhin, A. A. Ignatiev, Yuri E. Gorbachev, and Peter M. A. Sloot. Distributed Simulation of Silicon-Based Film Growth. In *PPAM '01: Proceedings of the 4th International Conference on Parallel Processing and Applied Mathematics-Revised Papers*, pages 879–887, London, UK, 2002. Springer-Verlag.

[72] V.V. Krzhizhanovskaya and V.V. Korkhov. Problem-Solving Environments for Simulation and Optimization on Heterogeneous Distributed Computational Resources of the Grid. In *Proceedings of the Third International Conference on Parallel Computations and Control Problems PACO’2006*, Moscow, Russia. Publ: Moscow, V.A. Trapeznikov Institute of Control Sciences RAS, pp. 917-932, 2006.


[74] V.V. Krzhizhanovskaya, V.V. Korkhov, A. Tirado-Ramos, D.J. Groen, I.V. Shoshmina, I.A. Valuev, I.V. Morozov, N.V. Malyskhin, Y.E. Gorbachev, and P.M.A. Sloot. Computational Engineering on the Grid: Crafting a Distributed Virtual Reactor. In *Second IEEE International Conference on e-Science and Grid Computing (e-Science’06)*, Amsterdam, the Netherlands, December 4-6 2006, pp.101. IEEE CS Press., 2006.

[75] V.V. Krzhizhanovskaya, P.M.A. Sloot, and Yu. E. Gorbachev. Grid-based Simulation of Industrial Thin-Film Production. *Simulation: Transactions of the Society for Modeling and Simulation International, V. 81, No. 1*, pp. 77-85, 2005.

[76] V.V. Krzhizhanovskaya, M.A. Zatevakhin, A.A. Ignatiev, Y.E. Gorbachev, W.J. Goedheer, and P.M.A. Sloot. A 3D Virtual Reactor for Simulation of Silicon-Based Film Production. In *Proceedings of the ASME/JSME PVP Conference. ASME PVP-Vol. 491-2, pp. 59-68, PVP2004-3120*, 2004.


